INFORMATION DISCLOSURE CITATION			ATTY. DOCKET NO.	SE	SERIAL NO.			
			25710-705	10-705 09/894,85%				
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Attachment to paper 0204